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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
YOSHIYUKI TERADA, ET AL. : EXAMINER: TRA, T. Q.
SERIAL NO: 09/926,657 :
FILED: NOVEMBER 29, 2001 : GROUP ART UNIT: 2873
FOR: ELECTRODE STRUCTURE OF EC :
MIRROR

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action dated July 16, 2002, please amend the above-identified application as follows:

IN THE SPECIFICATION

Please amend the specification as shown in the attached marked-up copy. A clean copy of the specification as amended is shown below.

Page 1, please replace line 1 with the following text:

TITLE OF THE INVENTION

Page 2, please replace the paragraph at lines 5 to 16 with the following text:

This EC mirror is provided with a lower transparent electrode (that is, a conductive layer) 3 serving as a first electrode, as illustrated in FIG. 4. ITO (indium tin oxide) film, SnO₂ and so on are used as the materials of the electrode 3. For instance, a first EC layer 4 colored by a reduction reaction, an electrolytic layer 5, a second EC layer 6 colored by an